Planar Hall effect sensor for magnetic micro- and nanobead detection

Ejsing, Louise Wellendorph; Hansen, Mikkel Foug; Menon, Aric Kumaran; Ferreira, H.A.; Graham, D.L.; Freitas, P.P.

Published in:
Applied Physics Letters

Link to article, DOI:
10.1063/1.1759380

Publication date:
2004

Document Version
Publisher's PDF, also known as Version of record

Link back to DTU Orbit

Citation (APA):
Planar Hall effect sensor for magnetic micro- and nanobead detection

L. Ejsing, a) M. F. Hansen, and A. K. Menon
Department of Micro and Nanotechnology (MIC), Technical University of Denmark (DTU), Building 345 East, DK-2800 Kongens Lyngby, Denmark

H. A. Ferreira, D. L. Graham, and P. P. Freitas
Institute of Engineering of Systems and Computers—Microsystems and Nanotechnologies (INESC-MN), Rua Alves Redol 9, Lisbon 1000-029, Portugal

(Received 26 January 2004; accepted 8 April 2004; published online 20 May 2004)

Magnetic bead sensors based on the planar Hall effect in thin films of exchange-biased permalloy have been fabricated and characterized. Typical sensitivities are 3 μV/Oe mA. The sensor response to an applied magnetic field has been measured without and with coatings of commercially available 2 μm and 250 nm magnetic beads used for bioapplications (Micromer-M and Nanomag-D, Micromod, Germany). Detection of both types of beads and single bead detection of 2 μm beads is demonstrated, i.e., the technique is feasible for magnetic biosensors. Single 2 μm beads yield 300 nV signals at 10 mA and 15 Oe applied field. © 2004 American Institute of Physics.

[DOI: 10.1063/1.1759380]

Detection of magnetic beads for bioapplications has been carried out with giant magnetoresistance (GMR) sensors,1–3 spin valve sensors,4–7 and a silicon Hall sensor.8 Planar Hall sensors have been used to detect nanotesla magnetic fields.9,10 This letter demonstrates that an exchange-biased permalloy planar Hall sensor can be used to detect magnetic micro- and nanomagnetic beads used for bioapplications.

Formerly, a planar Hall sensor made of nickel was demonstrated capable of detecting superparamagnetic microbeads.11 Here, we report on the use of permalloy as a sensing material since it has a higher anisotropic magnetoresistance (AMR) effect than nickel. To control the anisotropy and to achieve a well-defined single domain initial magnetization state, the permalloy layer is exchange coupled to a MnIr antiferromagnetic layer. The 200 Å thick exchange-biased permalloy, and the central area is the 10 μm×10 μm sensitive area of the sensor. Current leads are made of 0.3 μm thick Al. The top inset shows the planar Hall sensor geometry. The magnetic field to be detected is applied in the detection plane, along the y direction. In this plane, the current is applied in the x direction and the voltage, V y, is measured in the y direction. The bottom inset illustrates the cross-sectional layer structure of the sensor.

Planar Hall sensors have been used to detect nanotesla magnetic fields.9,10 This letter demonstrates that an exchange-biased permalloy planar Hall sensor can be used to detect magnetic micro- and nanobeads used for bioapplications.

The planar Hall effect is based on the AMR of ferromagnetic materials. The transverse voltage on a planar Hall cross plane. This changes the electrical output signal by the amount V y. For small angles, the signal can be expressed as

\[ V_y = \frac{(\rho_l - \rho_{\perp}) I_x}{t} \sin(\phi) \cos(\phi), \]

where \( t \) is the metal layer thickness, \( I_x \) is the applied current, and \( \phi \) is the angle between the current and the in-plane magnetization vector, \( \mathbf{M} \). \( \rho_l \) and \( \rho_{\perp} \) are the resistivities when the magnetization is parallel and perpendicular to the current, respectively. \( \Delta \rho = (\rho_l - \rho_{\perp}) \) is responsible for AMR and the planar Hall effect. For a 200 Å thick permalloy film, the resistivity variation is approximately 2.2%.13

A schematic drawing of the planar Hall sensor is presented in the inset of Fig. 1. Initially, the magnetization lies along the easy axis, which is also the direction of the applied current, \( I_x \). When a magnetic field, \( H_y \), is applied in the y direction, the magnetization rotates by an angle \( \phi \) in the sensor plane. This changes the electrical output signal by the amount \( V_y \).

\[ V_y = \frac{(\rho_l - \rho_{\perp}) I_x}{t} \frac{H_y}{H_{an}}. \]

Therefore, in small applied fields compared to the anisotropy field, the response of the sensor is linear. For bead detection, \( H_{an} \) in expression (2) represents the applied external field plus the sum of the y components of the field created by the homogeneously magnetized spherical beads weighted by the bead-to-sensor area fraction.

A micrograph of the cleanroom fabricated planar Hall sensor is shown in Fig. 1. The sensor layer structure Ta (30 Å)/NiFe (50 Å)/MnIr (200 Å)/NiFe (200 Å)/Ta (30 Å) (see

---

a)Electronic mail: loe@mic.dtu.dk

---

FIG. 1. Micrograph of the planar Hall sensor. The cross is made of exchange-biased permalloy, and the central area is the 10 μm×10 μm sensitive area of the sensor. Current leads are made of 0.3 μm thick Al. The top inset shows the planar Hall sensor geometry. The magnetic field to be detected is applied in the detection plane, along the y direction. In this plane, the current is applied in the x direction and the voltage, V y, is measured in the y direction. The bottom inset illustrates the cross-sectional layer structure of the sensor.
cross-sectional diagram in the inset of Fig. 1) was prepared by ion-beam deposition on a passivated 3 in. Si wafer, then covered by sputtered antireflecting TiWN (150 Å). Ion-beam deposition conditions are given in Gehanno et al.13 Here, MnIr stands for Mn70Fe24 and NiFe stands for Ni80Fe20. During ion-beam metal deposition, a magnetic field of 40 Oe was applied in order to form an easy axis in the ferromagnetic NiFe layers. Sensors (crosses of 10 μm×10 μm) were patterned by direct write laser lithography and ion-beam milling. Al current leads (0.3 μm thick) were sputtered after a soft etch of the contact surface and defined by photolithography and lift off. The sensor structure was then passivated by a sputtered SiO2 (2000 Å) layer and contact pads were opened by reactive ion etching.

The active sensing layer is the NiFe (200 Å) layer. For characterization of the planar Hall sensors, electromagnetic coils were used to provide a tuneable magnetic field and the sensor response signal was measured as a function of applied field strength. Direct currents of 1, 5, and 10 mA are applied and direct voltage drops are measured using a voltmeter; no electronic noise reduction is used. A typical sensitivity is $S = \frac{3 \, \mu V}{Oe \, mA}$ in the range of ±15 Oe, where the signal is linear within 2.8%. This sensitivity is reproducible for a specific sensor and for sensors on the same chip.

For demonstration of bead detection, a droplet containing superparamagnetic Micromod beads (2 μm or 250 nm diameter,14 physical properties are summarized in Table I) was placed on top of the sensor while measuring the voltage drop. The beads were magnetized with a −15 Oe in-plane applied field generated by electromagnetic coils leading to estimated local dipole fields just below the beads of +1.5 Oe for 2 μm beads, and +30 Oe for 250 nm beads.

Figure 2 presents the bead detection results. Current through the sensor is 5 mA and the applied field is −15 Oe. At time $t = 100$ s, the 2 μm beads are added onto the chip and the signal rises as the beads settle on the sensor. Then, at time $t = 300$ s, the beads are washed away and the signal returns to the baseline. At times $t = 700$ s and $t = 1050$ s, respectively, the experiment is repeated yielding the same result. At time $t = 1400$ s, the 250 nm beads are added to the chip and at time $t = 1650$ s the beads are washed away. The experiment is repeated with the 250 nm beads at times $t = 2250$ s and $t = 2650$ s, respectively. The 250 nm beads give higher saturation signals than the 2 μm beads due to their higher susceptibility and higher number on top of the sensor area. Saturation of the signal occurs when the beads are piled up on top of the sensor and the addition of another bead is no longer sensed because it is too far away from the sensor to be detected.

Figure 3 shows sensor response to an increasing or decreasing number of beads over the sensing area (2 μm Micromod-M beads). Current through the sensor is 10 mA and applied field is −15 Oe. The estimate of how many beads are floating over the sensitive area at a given time is carried out by visual inspection through a microscope during the measurements. Specifically, the large numbers of beads

<table>
<thead>
<tr>
<th>Diameter</th>
<th>Concentration</th>
<th>Density</th>
<th>$\chi$</th>
</tr>
</thead>
<tbody>
<tr>
<td>Micromod-M</td>
<td>2 μm</td>
<td>&gt;25 mg/ml</td>
<td>1.4 g/cm³</td>
</tr>
<tr>
<td>Nanomag-D</td>
<td>250 nm</td>
<td>&gt;10 mg/ml</td>
<td>4.0 g/cm³</td>
</tr>
</tbody>
</table>

$^a$See Ref. 14.
$^b$Measured at Institute of Engineering of Systems and Computers—Microsystems and Nanotechnologies (INESC–MN).
are connected with uncertainty since it is difficult to judge the exact number of beads constituting a cluster. For low bead numbers, the resulting one-bead signal is $V_{\text{bead}} \sim 0.3 \mu V$. The noise level for these dc measurements is 200–300 nV.

In conclusion, detection of commercially available 2 $\mu$m and 250 nm superparamagnetic beads (Micromod-M and Nanomag-D)\textsuperscript{14} used for bioapplications was demonstrated using an exchange-biased permalloy planar Hall sensor. Hence, this planar Hall sensor has potential as a magnetic biosensor, e.g., for deoxyribonucleic acid detection. The technique is sufficiently sensitive to detect only a few magnetic beads and therefore also biomolecules even if only few are present in the sample. For small numbers of 2 $\mu$m beads, bead detection experiments showed a single-bead signal of $V_{\text{bead}} \sim 0.3 \mu V$.

Due to the cross geometry, the planar Hall sensor uses all its active surface for bead/biomolecule detection, which is not the case for meandering-type GMR or spin valve sensors, where almost one-half of the target biomolecules will sit over a nonsensing area. A second advantage, not exploited here, concerns the theoretically higher signal-to-noise (S/N) ratio for planar Hall sensors when compared with GMR or spin valve sensors. For comparable sensing areas, although the spin valve sensor yields signals 5 to 10 times higher, the planar Hall sensor should have a noise level in the $1/f$ dominated low-frequency regime) about 20 times lower offering the possibility of single bead detection for nanometer-sized beads.

Using a lock-in amplifier to obtain a bandwidth of 1 Hz will improve the S/N considerably. For the reported sensor size with an applied current of 15 mA and defining the minimum detectable signal as four times the noise level, the theoretical $1/f$ noise level is $\approx 0.6$ nV and the sensor should be able to detect a single 250 nm bead. If the sensor size is reduced to 2.5 $\mu$m$\times$2.5 $\mu$m and the current is reduced to 10 mA, it should be possible to detect a single 40 nm bead with $\chi = 6$ (SI).

Future work includes integration with microfluidic systems along with a demonstration of the planar Hall sensor as a biosensor and single micro- and nanobead detection.

\textsuperscript{9} F. Montaigne, A. Schuhl, F. N. Van Dau, and A. Encinas, Sens. Actuators 81, 324 (2000).
\textsuperscript{14} http://www.micromod.de